

Notice of References Cited	Application/Control No. 10/660,576		Applicant(s)/Patent Under Reexamination HONG, CHI-JEN	
	Examiner TAN TRINH		Art Unit 2684	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0039873	11-2001	Yi et al.	84/610
*	B	US-2004/0204135 A1	10-2004	Zhao et al.	455/566
*	C	US-2004/0047290 A1	03-2004	Komandur et al.	370/230
*	D	US-6,549,767 B1	04-2003	Kawashima, Takahiro	455/412.2
*	E	US-2002/0082007 A1	06-2002	Hoisko et al.	455/426
*	F	US-2003/0129956 A1	07-2003	Virolainen, Jussi	455/306
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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